

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Li et al.

Serial No.: 10/759,448

Filed: 01/16/2004

SPIN-ON PROTECTIVE COATINGS FOR WET-  
ETCH PROCESSING OF MICROELECTRONIC  
SUBSTRATES

Docket No.: 34393

Conf. No. 7830

Group Art Unit No.: 1773

Examiner: Jackson, Monique R.

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In response to the office action dated March 9, 2007, amendment and reconsideration of the above application is requested.